

Canada's national laboratory for particle and nuclear physics and accelerator-based science

A review of chemically selective ion sources for radioisotope production at ISOL facilities

Tom Day Goodacre 16th October 2017





- 1. What is a thick target ISOL facility?
- 2. What does this mean for ion source requirements?
- Ion source types: challenges, development highlights and directions for the future
 3.1 Surface ion sources
 - 3.2 FEBIAD type ion sources
 - 3.3 RILIS
 - 3.4 Blurred boundaries
- 4. Summary





1. What is a thick target ISOL facility?



ISOL = Isotope Separator On-Line

<u>1951</u>

Short-Lived Krypton Isotopes and Their Daughter Substances

O. KOFOED-HANSEN AND K. O. NIELSEN Institute for Theoretical Physics, University of Copenhagen, Copenhagen, Denmark (Received February 9, 1951)

THE isotopes Kr⁸⁹, Kr⁹⁰, Kr⁹¹ and their daughter substances have been investigated. Krypton formed in fission of uranium was pumped through a 10-m long tube directly from the cyclotron into the ion source of the isotope separator. The cyclotron and the isotope separator were operated simultaneously, and the counting could begin immediately after the interruption of the separation. The rubidium and strontium daughter substances

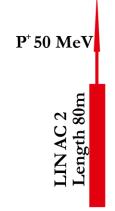
http://dx.doi.org/10.1103/PhysRev.82.96.2

"...Krypton formed in fission of uranium was pumped through a 10-m long tube directly from the cyclotron into the ion source of the isotope separator. The cyclotron and the isotope separator were operated **simultaneously**..."



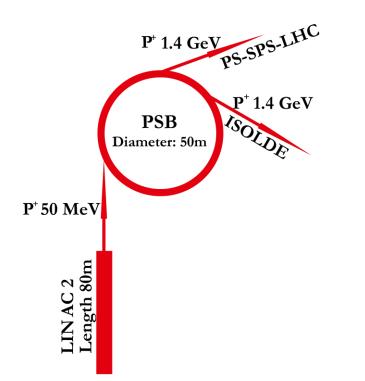






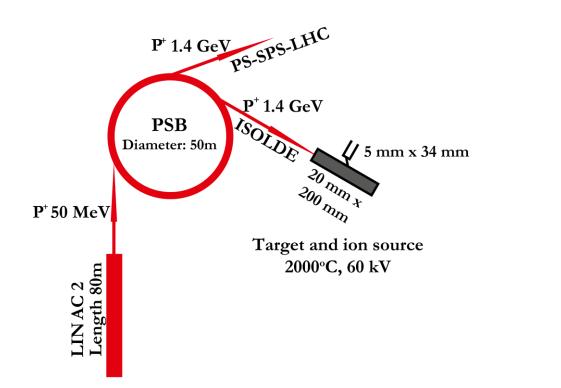




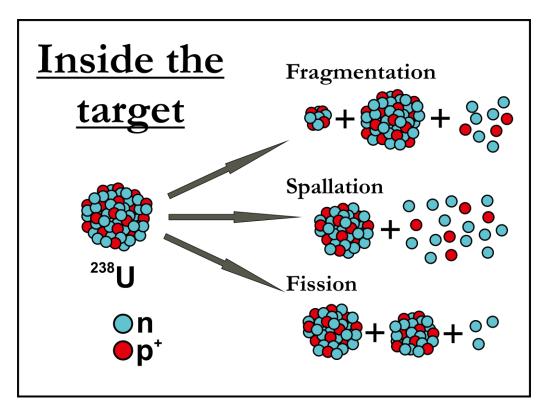








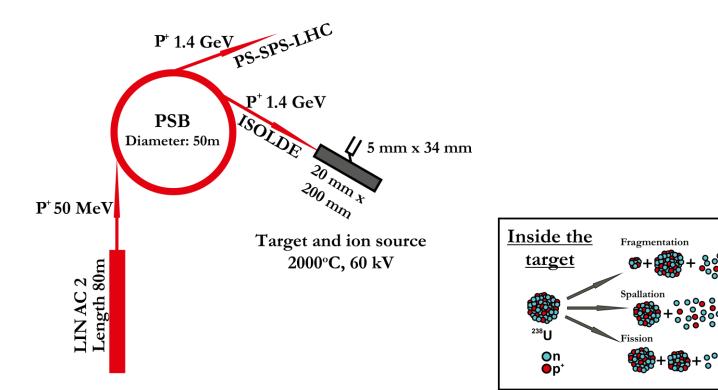




ICIS 2017 Chemically selective ISOL ion sources

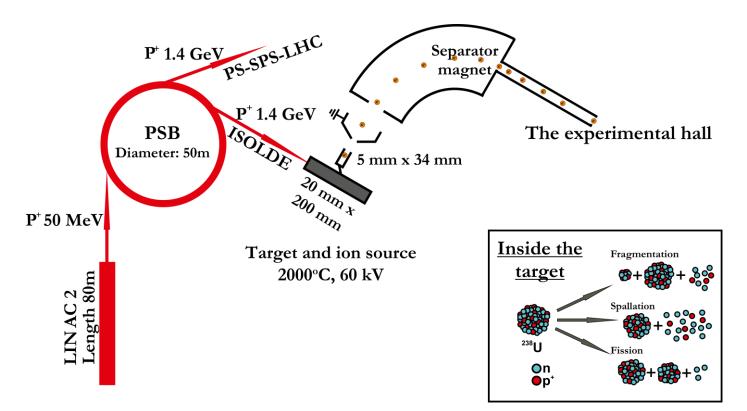






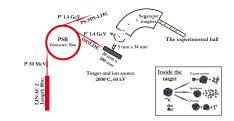








Happy Birthday ISOLDE!



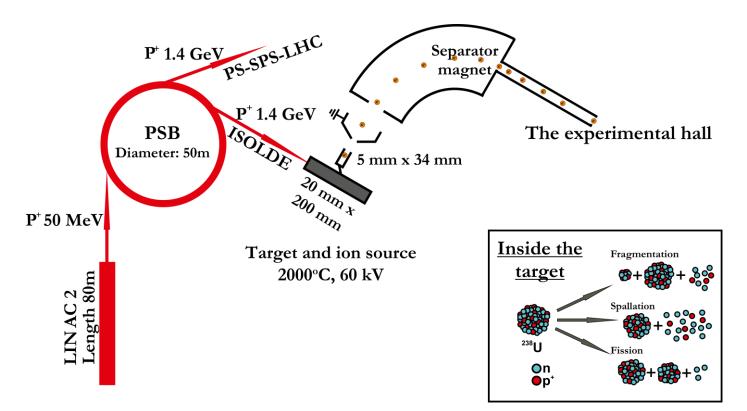


First radioactive ion beam 16th October 1967

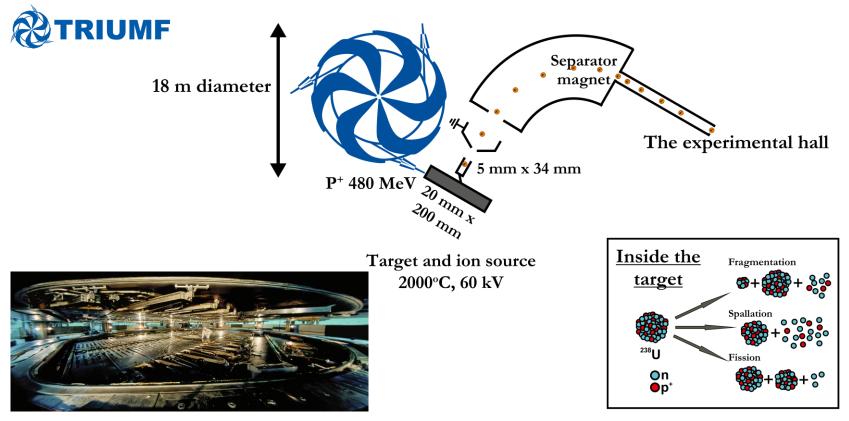
ICIS 2017 Chemically selective ISOL ion sources











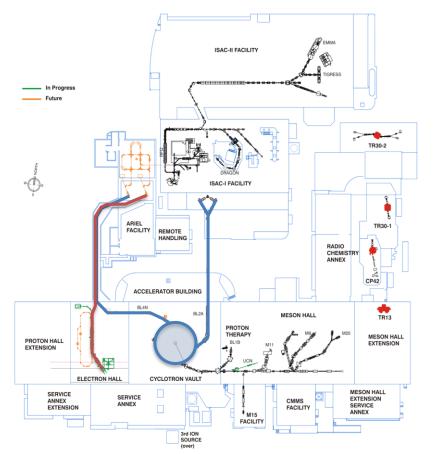
TRIUMF

ISAC (currently):

- 480 MeV, \leq 100 μ A proton driver beam
- Two target stations (ITE, ITW), alternating operation

ARIEL (under construction):

- Two independent target stations
- 480 MeV, ≤100 μA proton driver beam
- ≤ 50 MeV, ≤10 mA electron driver beam
- RIB beam through beam transport and CANREB system to ISAC experiments
- 9000 hours of RIB available annually: Requires both reliability + new beams!



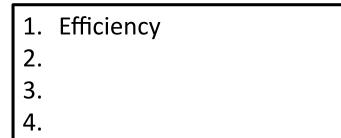




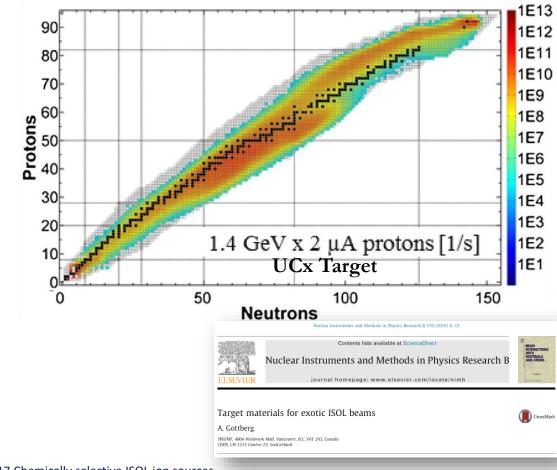
- 1. What is a thick target ISOL facility?
- 2. What does this mean for ion source requirements?

RIUMF

Ion source requirements @ thick target ISOL



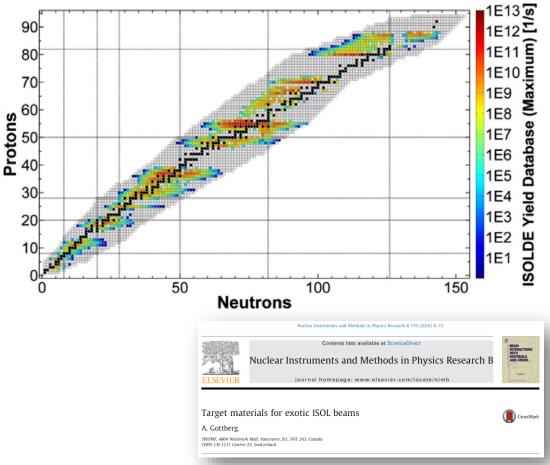
- A fixed amount of the isotope of interest
- The interest in an isotope is often inversely proportional to its production rate



RIUMF

Ion source requirements @ thick target ISOL

- 1. Efficiency
- 2. Extraction/ionization time
- 3.
- 4.
- The effects of chemical reactions and low volatility is apparent in the extracted yields
- For a t_{1/2}=5 ms isotope, a 100 ms delay is a loss factor of 10⁶

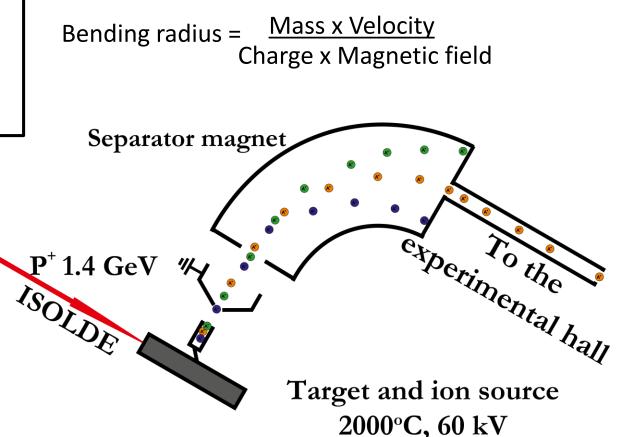


RTRIUMF

Ion source requirements @ thick target ISOL

- 1. Efficiency
- 2. Extraction/ionization time
- 3. Ion beam "quality"
- 4.

The transverse emittance and the longitudinal energy spread affect the effectiveness of mass separation



TRIUMF

Ion source requirements @ thick target ISOL

- 1. Efficiency
- 2. Extraction/ionization time
- 3. Ion beam "quality"

Nuclear Instruments and Methods 186 (1981) 275–293 North-Holland Publishing Company

Part V. Ion sources techniques

PROGRESS IN ION SOURCE DEVELOPMENT FOR ON-LINE SEPARATORS

R. KIRCHNER GSI Darmstadt, Postfach 110541, D-6100 Darmstadt 11, FRG

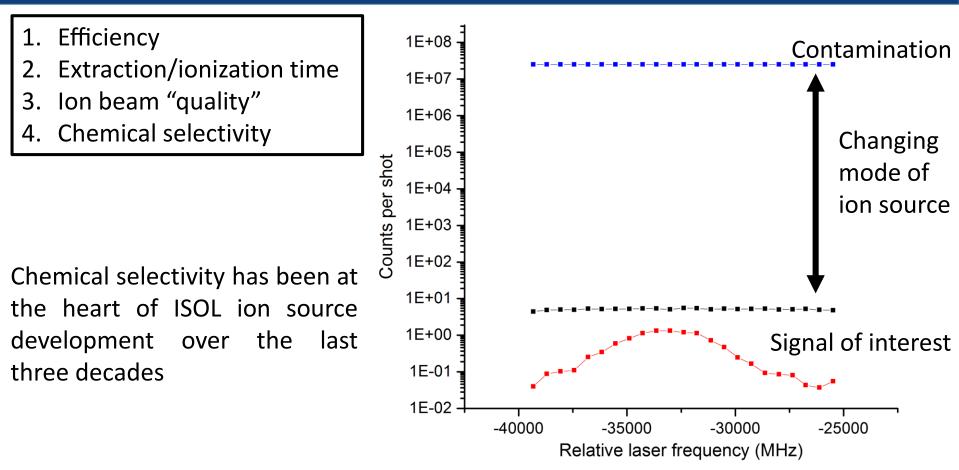
<u>1981</u>

4.

"...the development of ion sources during the last decade has made most elements accessible to an effective *ionization* and consequently has led to the situation, where successful application to ISOL depends almost exclusively on the extent to which the release problems have been overcome."

TRIUMF

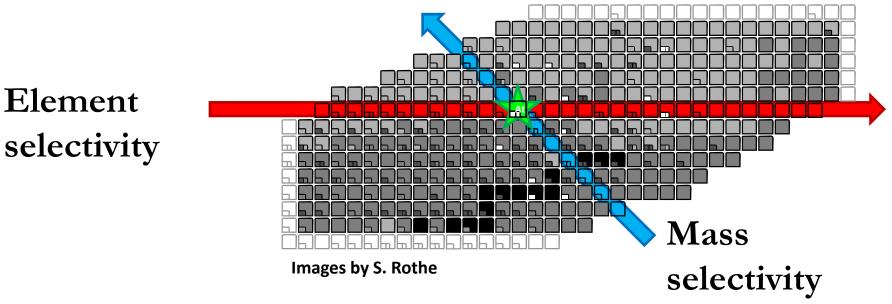
Ion source requirements @ thick target ISOL



Ion source requirements @ thick target ISOL

- 1. Efficiency
- 2. Extraction/ionization time
- 3. Ion beam "quality"
- 4. Chemical selectivity

Isotope specific purification







- 1. What is a thick target ISOL facility?
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- Ion source types: challenges, development highlights and directions for the future
 3.1 Surface ion sources



<u>1971</u>

NUCLEAR INSTRUMENTS AND METHODS 96 (1971) 437-439; © NORTH-HOLLAND PUBLISHING CO.

A NEW METHOD FOR RARE-EARTH ISOTOPE SEPARATION

G. J. BEYER, E. HERRMANN, A. PIOTROWSKI, V. J. RAIKO and H. TYRROFF

Laboratory of Nuclear Problems, Joint Institute for Nuclear Research, Dubna, USSR



NUCLEAR INSTRUMENTS AND METHODS 106 (1973) 83-87; © NORTH-HOLLAND PUBLISHING CO.

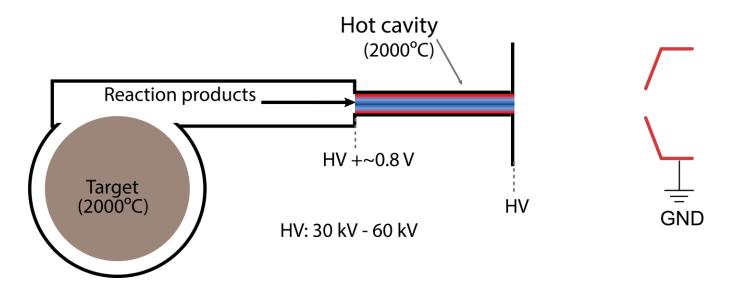
A HIGH TEMPERATURE ION SOURCE FOR ISOTOPE SEPARATORS*

P. G. JOHNSON, A. BOLSON and C. M. HENDERSON

Lawrence Livermore Laboratory, University of California, Livermore, California 94550, U.S.A.

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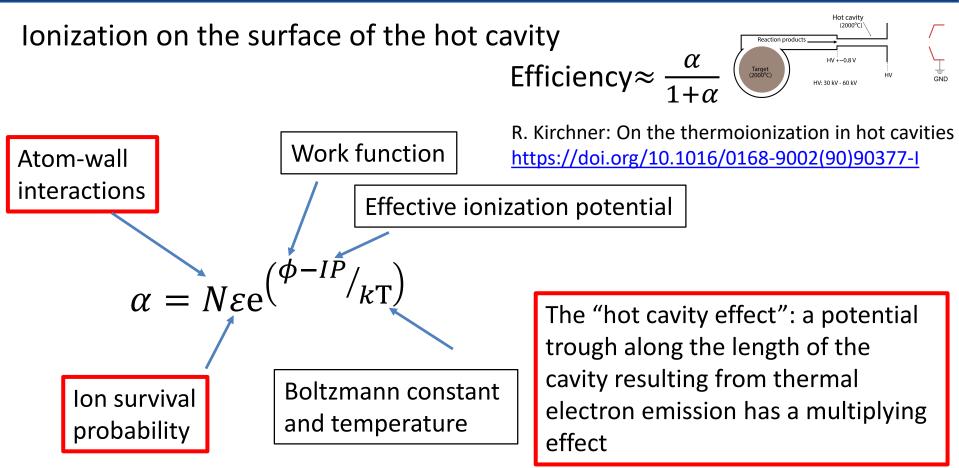




ICIS 2017 Chemically selective ISOL ion sources

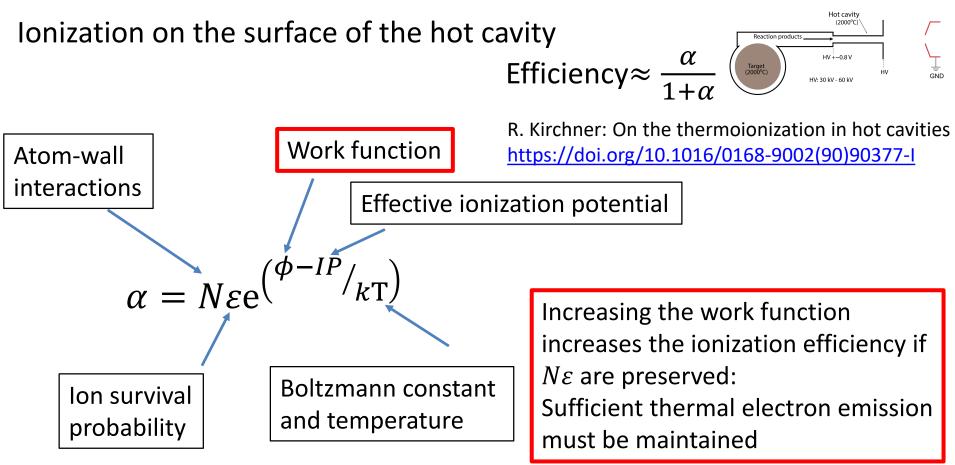


Surface ion sources





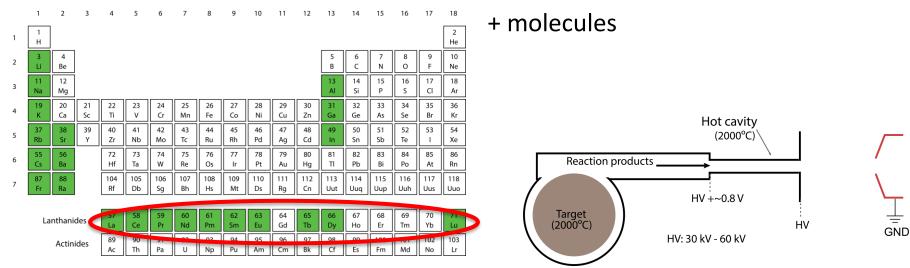
Surface ion sources





- 1. Efficiency: ionization potential and material dependent
- 2. Extraction/ionization time: ~100 μs (not considering sticking times)
- 3. Chemical selectivity: element dependent

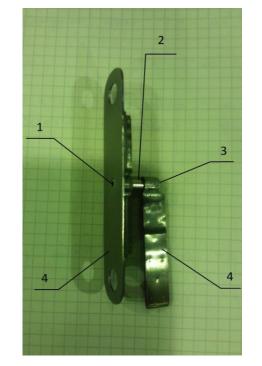
Often applied for:



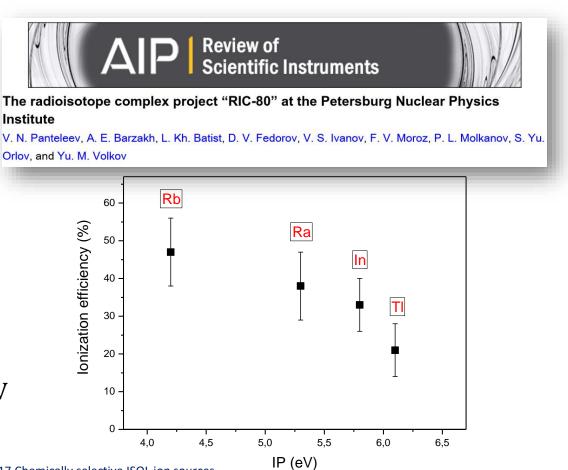
TRIUMF

Surface ion sources: development highlight





Single crystal tungsten cavity $\phi \approx 5 \ {\rm eV}$ 2400°C



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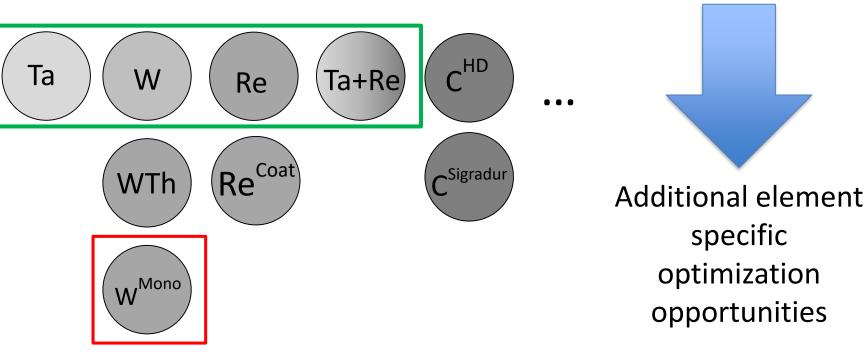
Development prospects: Materials!



specific

optimization

opportunities



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FEBIAD-type ion sources: milestones

FEBIAD: Forced Electron Beam Induced Arc Discharge

1976 The first FEBAID

NUCLEAR INSTRUMENTS AND METHODS 139 (1976) 291-296; © NORTH-HOLLAND PUBLISHING CO.

A NOVEL ISOL ION SOURCE

R. KIRCHNER* and E. ROECKL

GSI Darmstadt, D-61 Darmstadt 1, Postfach 541, W. Germany

A new plasma ion source of Nielsen-type geometry is described permitting operation as normal arc discharge, forced electron beam induced arc discharge or as surface ionization source. Off-line and on-line performances with halogen, noble gas and alkali elements are discussed.

> Nuclear Instruments and Methods in Physics Research B70 (1992) 160-164 North-Holland

Introduction of selectivity

Ion source with combined cathode and transfer line heating

S. Sundell, H. Ravn and the ISOLDE Collaboration

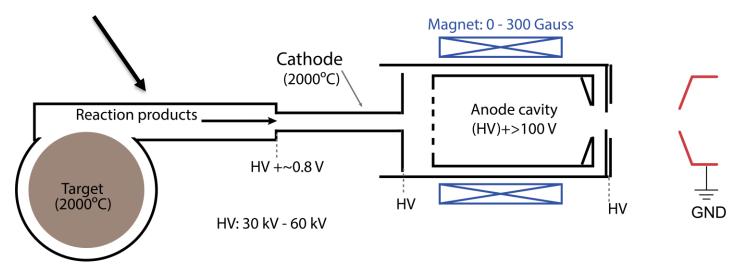
CERN, CH-1211 Geneva 23, Switzerland

eam Interactions



FEBIAD: Forced Electron Beam Induced Arc Discharge

Selectivity introduced through temperature control of the transfer line



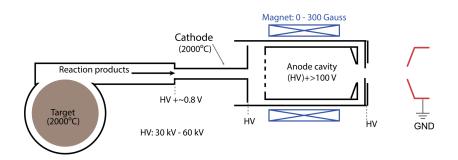


- 1. Efficiency: ~universal typically 1-50 %
- 2. Extraction/ionization time: ~10-100 ms (neglecting sticking times)
- 3. Chemical selectivity: Introduced via transfer line development

Selective operation for:

	1	2	3	4	5	6	7	8	9	10	11	12	13	14	15	16	17	18
1	1 H																	2 He
2	3 Li	4 Be											5 B	6 C	7 N	8 0	9 F	10 Ne
3	11 Na	12 Mg											13 Al	14 Si	15 P	16 S	17 Cl	18 Ar
4	19 K	20 Ca	21 Sc	22 Ti	23 V	24 Cr	25 Mn	26 Fe	27 Co	28 Ni	29 Cu	30 Zn	31 Ga	32 Ge	33 As	34 Se	35 Br	36 Kr
5	37 Rb	38 Sr	39 Y	40 Zr	41 Nb	42 Mo	43 Tc	44 Ru	45 Rh	46 Pd	47 Ag	48 Cd	49 In	50 Sn	51 Sb	52 Te	53 I	54 Xe
6	55 Cs	56 Ba		72 Hf	73 Ta	74 W	75 Re	76 Os	77 Ir	78 Pt	79 Au	80 Hg	81 Tl	82 Pb	83 Bi	84 Po	85 At	86 Rn
7	87 Fr	88 Ra		104 Rf	105 Db	106 Sg	107 Bh	108 Hs	109 Mt	110 Ds	111 Rg	112 Cn	113 Uut	114 Uuq	115 Uup	116 Uuh	117 Uus	118 Uuo
	Lanthanides				58 Ce	59 Pr	60 Nd	61 Pm	62 Sm	63 Eu	64 Gd	65 Tb	66 Dy	67 Ho	68 Er	69 Tm	70 Yb	71 Lu
	Actinides			89 Ac	90 Th	91 Pa	92 U	93 Np	94 Pu	95 Am	96 Cm	97 Bk	98 Cf	99 Es	100 Fm	101 Md	102 No	103 Lr

Dedicated arc discharge ion source for ISOL: operation over a range of pressures down to 10⁻⁵ mbar





FEBIAD-type ion sources: simulations

FEBIAD: Forced Electron Beam Induced Arc Discharge

REVIEW OF SCIENTIFIC INSTRUMENTS 81, 02A906 (2010)

Development of high efficiency Versatile Arc Discharge Ion Source at CERN ISOLDE^{a)}

L. Penescu,^{b)} R. Catherall, J. Lettry, and T. Stora *CERN, CH-1211, Geneva 23, Switzerland*

(Presented 24 September 2009; received 21 September 2009; accepted 11 November 2009; published online 19 February 2010)



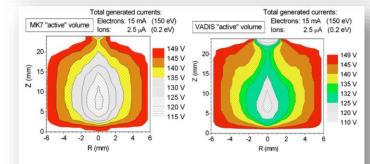
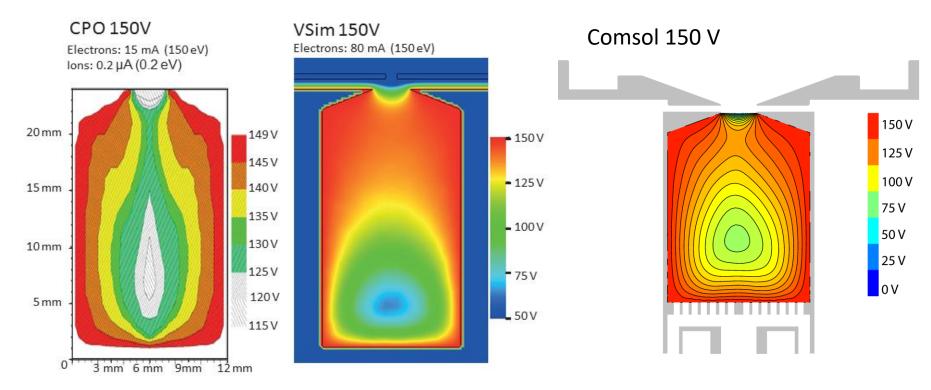


FIG. 3. (Color online) Potential contours inside MK7 (left) and MK5/ VADIS (right) that can serve to estimate the active volumes and to justify Simulations and testing improved understanding of FEBIAD anode geometries at ISOLDE, the Standardised source was renamed the VADIS



Simulation validation

Off-line and on-line ion source tests ongoing



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Directions for the future: FEBIAD understanding

Simulation and characterization





Y. Martinez

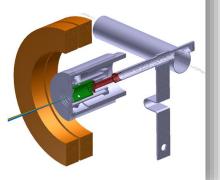
12:10 Wednesday



Study and optimization of the VADLIS ion source for the

production of radioactive beams at ISOLDE

Yisel Martinez Palenzuela PhD student KU Leuven/CERN

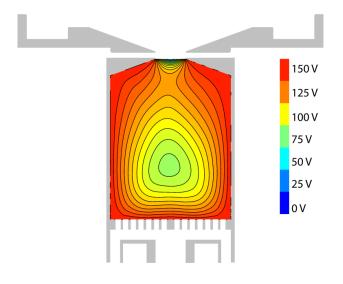


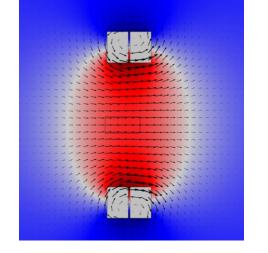


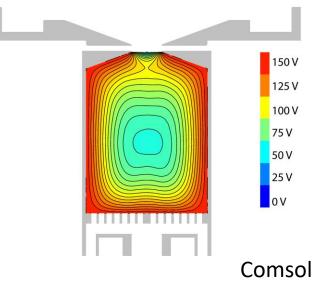
Simulation and characterization



Influence of the magnetic field







PhD of F. Maldonado

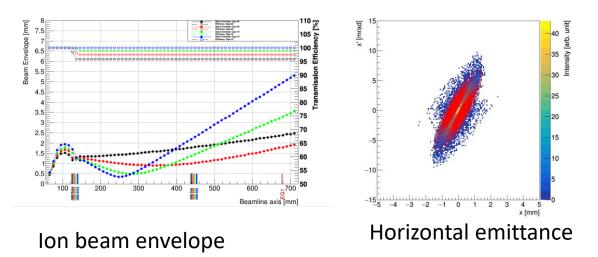
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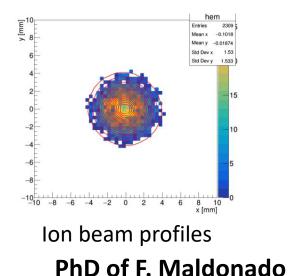


"Observable values" extracted for surface and FEBIAD ion sources

- Emittance
- Ion beam envelope

Simulation validation ongoing at the ISAC test stand

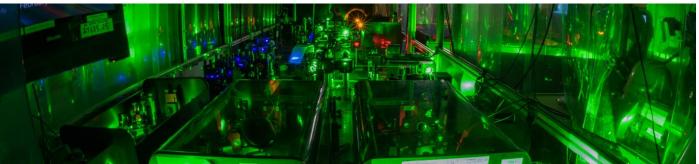






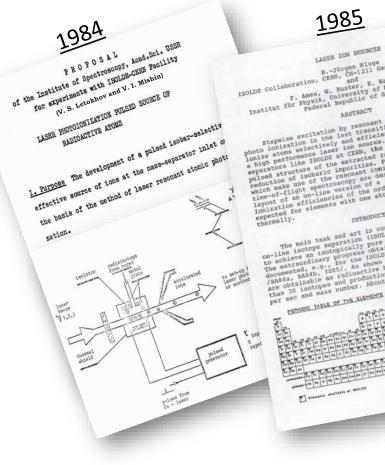


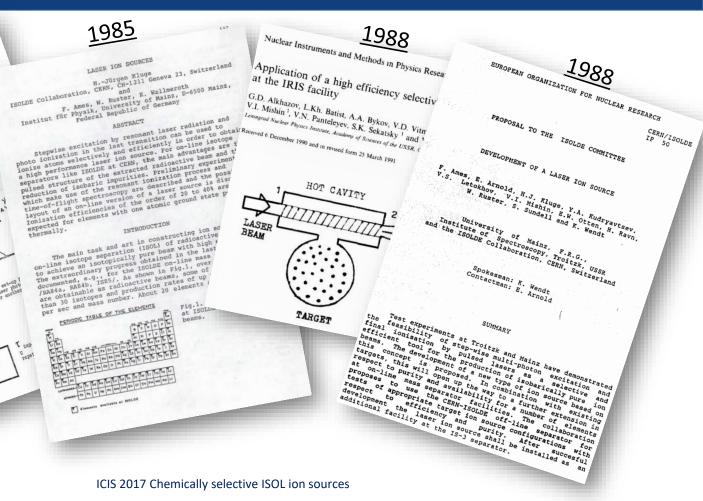
- 1. What is a thick target ISOL facility?
- 2. What does this mean for ion source requirements?
- Ion source types: challenges, development highlights and directions for the future
 3.1 Surface ion sources
 - 3.2 FEBIAD type ion sources
 - **3.3 RILIS**





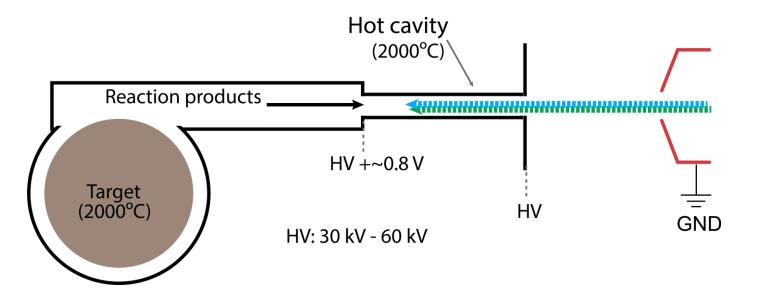
RILIS (Resonance ionization laser ion source): origins





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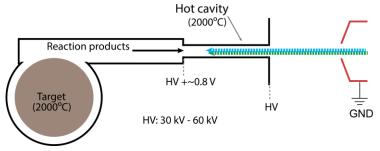
RILIS: principals

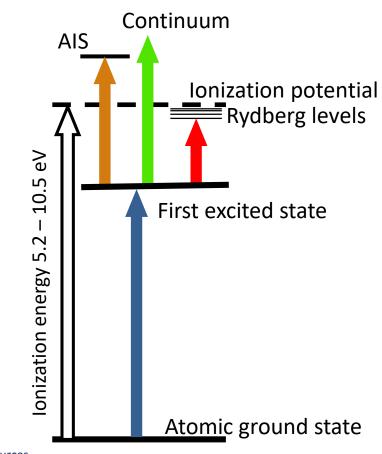
Stepwise resonance ionization

Multiple tuneable lasers target element unique atomic resonances

lonizing step:

- Autoionizing state
- Ionization to the continuum
- Ionization via Rydberg levels







RILIS: principals

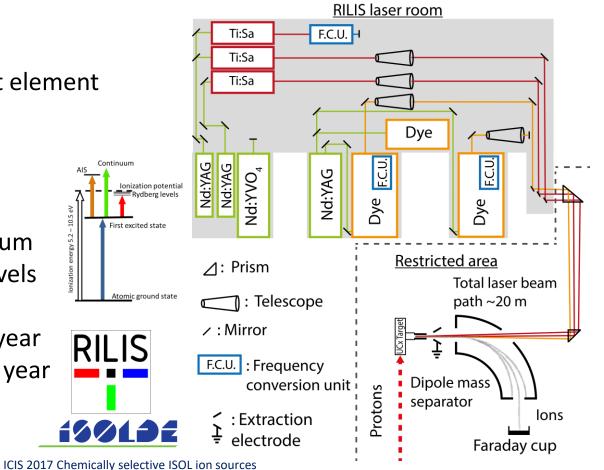
Stepwise resonance ionization

Multiple tuneable lasers target element unique atomic resonances

lonizing step:

- Autoionizing state
- Ionization to the continuum
- Ionization via Rydberg levels

>75 % of ISOLDE physics each year>60 % of TRIUMF physics each year

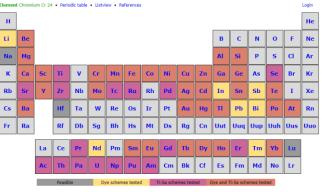






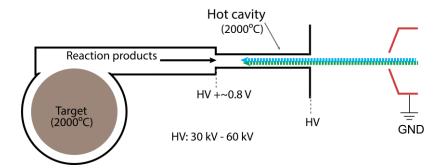
- 1. Efficiency: ~1-40%
- 2. Extraction/ionization time ~100 μ s (not considering sticking times)
- 3. Chemical selectivity: process is selective, may not be the only ionization mechanism

Element selective \rightarrow an ionization scheme must be developed for each element



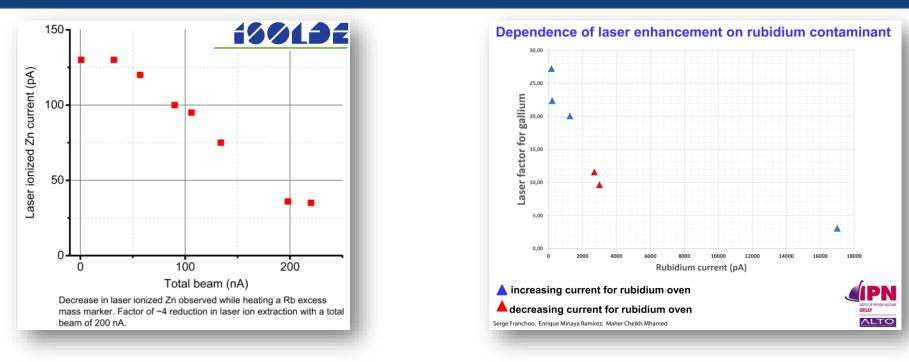
RILIS Elements

https://riliselements.web.cern.ch/riliselements/index.php





RILIS/general: upcoming challenges

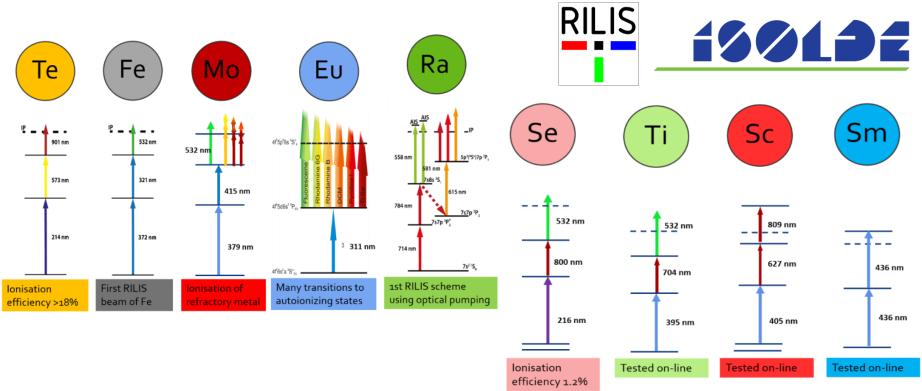


The efficiency of the ion survival/extraction can be severely reduced by total ion currents >100 nA. Higher limit for FEBIADS though more universal ionization method. A potential issue for new target materials and "high power" facilities.

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Ionization scheme development at the ISOLDE RILIS 2016-2017





ICIS 2017 Poster:

Resonant Ionization of Atomic Tellurium with Ti:Sapphire Lasers

Y. Liu¹, T. Kieck², D. W. Stracener¹, K. D. A. Wendt²

¹Physics Division, Oak Ridge National Laboratory, Oak Ridge, TN 37831, USA ²Institut für Physik, Johannes Gutenberg-Universität Mainz, D-55128 Mainz, Germany

MOTIVATION

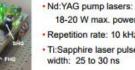
- Resonance ionization laser ion sources have become essential tools for the production of isobarically pure radioactive ion beams for nuclear research [1]
- Efficient resonant ionization of beams of atomic tellurium using a combination of Ti:Sapphire and dye lasers has been recently reported [2]. However, the ionization schemes are not applicable to laser ion sources equipped only with Ti:Sapphire lasers
- This study investigates potential resonant ionization schemes of tellurium using only Ti-Sannhire lasers

LASER SYSTEM

Three Ti:Sapphire lasers, three Q-switched, frequency-doubled Nd:YAG pump lasers, and frequency doubling (SHG), tripling (THG), and quadrupling (FHG) units



Figure 1. Photos of the Ti:Sapphire laser system for the RILIS at ORNL



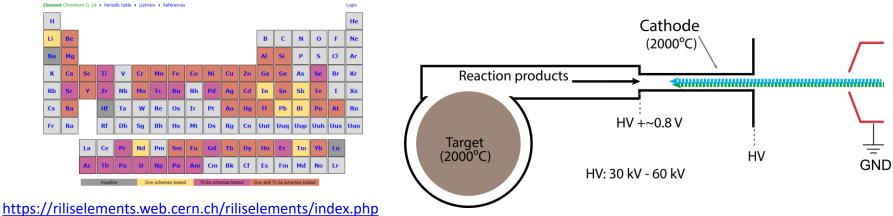
18-20 W max. power · Repetition rate: 10 kHz Ti:Sapphire laser pulse width: 25 to 30 ns

Tuesday #72 Y. Liu



- 1. Efficiency: ~1-40%
- 2. Extraction/ionization time ~100 µs (not considering sticking times)
- 3. Chemical selectivity: process is selective, may not be the only ionization mechanism

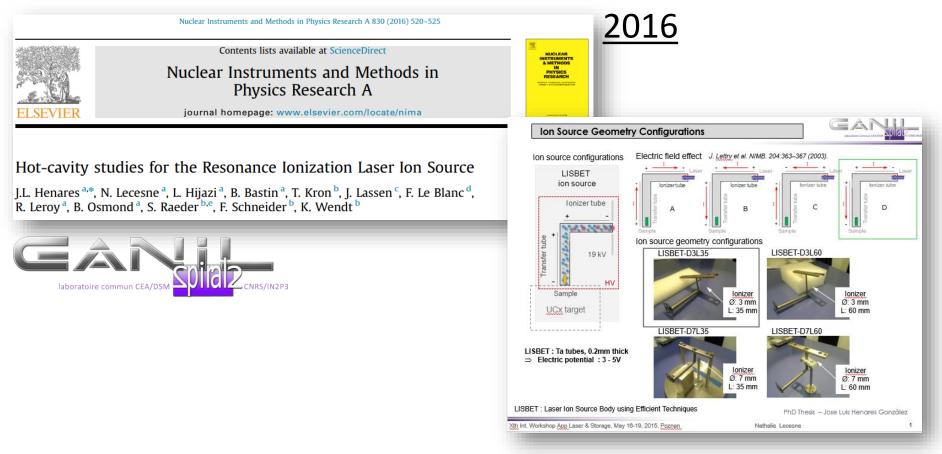
Element selective \rightarrow an ionization scheme must be developed for each element



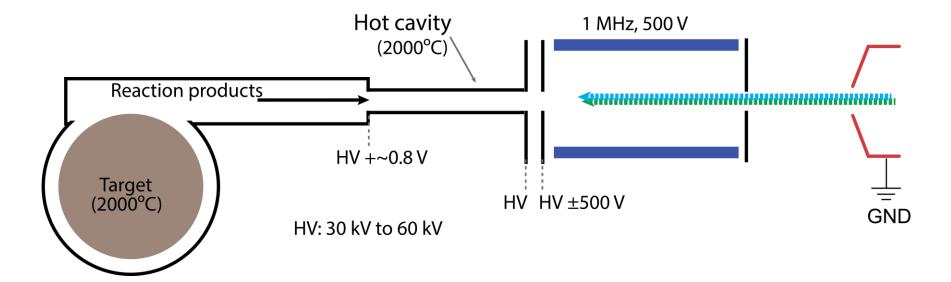
RILIS Elements



RILIS developments: cavity investigations



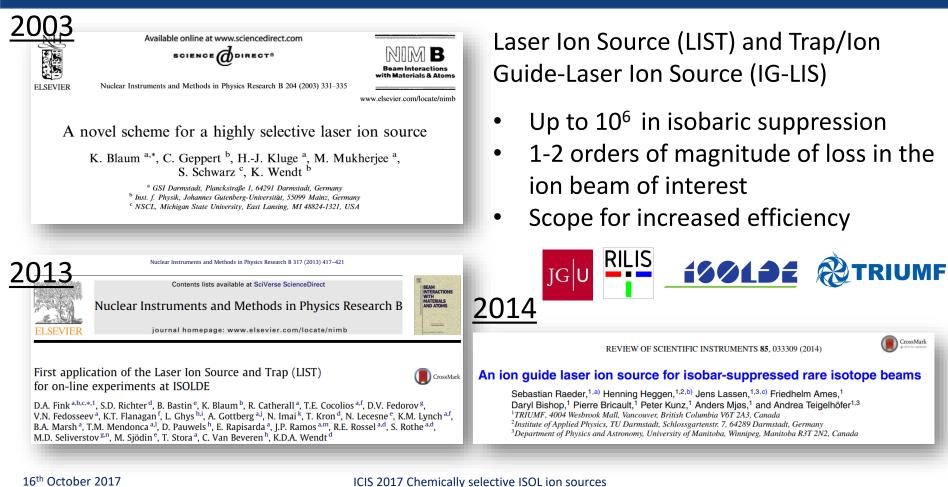






RILIS developments: LIST/IG-LIS

CrossMark





Can we be more selective?

The selectivity frontier: isotope/isomer specific ionization



EUROPEAN ORGANIZATION FOR NUCLEAR RESEARCH

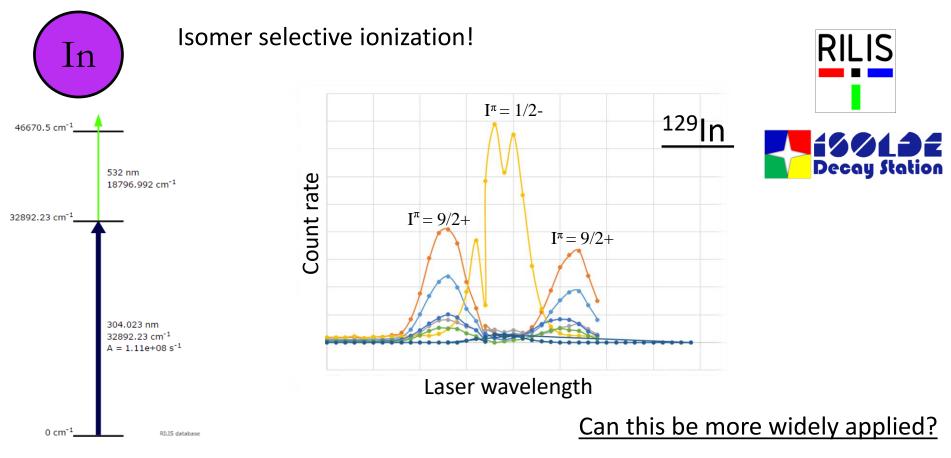
Proposal to the ISOLDE and Neutron Time-of-Flight Committee

Gamma and fast-timing spectroscopy of the doubly magic ¹³²Sn and its one- and two-neutron particle/hole neighbours

October 12, 2015

L.M. Fraile¹, A. Korgul², A. Gargano³, A. Aprahamian⁴, A. Algora⁵, G. Benzoni⁶, M.J.G. Borge⁷, M. Carmona¹, C. Costache⁸, A. Covello⁹, H. Duckwitz¹⁰,
P. Van Duppen¹¹, V. Fedosseev⁷, G. Fernández-Martínez¹², D. Ghiţă⁸, T. Grahn^{13,14},
P.T. Greenlees^{13,14}, R. Grzywacz^{15,16}, C. Henrich¹², P. Hoff¹⁷, M. Huyse¹¹, T. Ilieva¹², Z. Janas², A. Jokinen¹³, J. Jolie¹⁰, M. Karny², M. Kicińska-Habior², Th. Kröll¹²,
W. Kurcewicz², U. Köster¹⁸, S. Lalkovski¹⁹, R. Lică⁷, M. Madurga⁷, N. Mărginean⁸,
R. Mărginean⁸, B. Marsh⁷, C. Mazzocchi², C. Mihai⁸, R.E. Mihai⁸, A.I. Morales⁶, K. Moschner¹⁰, S. Nae⁸, A. Negret⁸, V. Paziy¹, M. Piersa², P. Rahkila^{13,14},
J. Pakarinen^{13,14}, J.-M. Régis¹⁰, E. Ruchowska²⁰, K.P. Rykaczewski¹⁶, G. Simpson²¹, Ch. Sotty⁸, M. Stanoiu⁸, M. Stryjczyk², O. Tengblad²², A. Turturica⁸, J.M. Udías¹, V. Vedia¹, W.B. Walters²³, N. Warr¹⁰, H. De Witte¹¹.





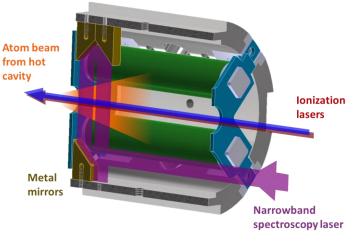
16th October 2017



ICIS 2017 Poster:



Tuesday #63 R. Heinke



The Perpendicularly Illuminated Laser Ion Source & Trap **PI-LIST**

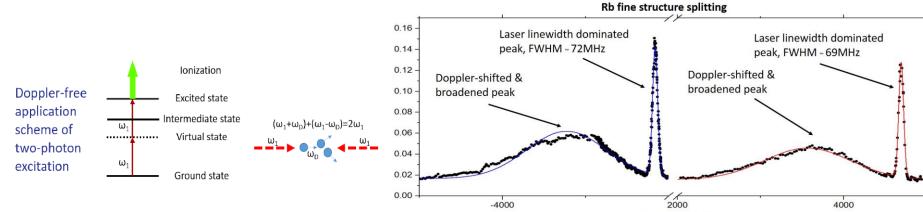


RILIS: Extending isomer selective ionization

ICIS 2017 Poster:

Tuesday #68 K. Chrysalidis





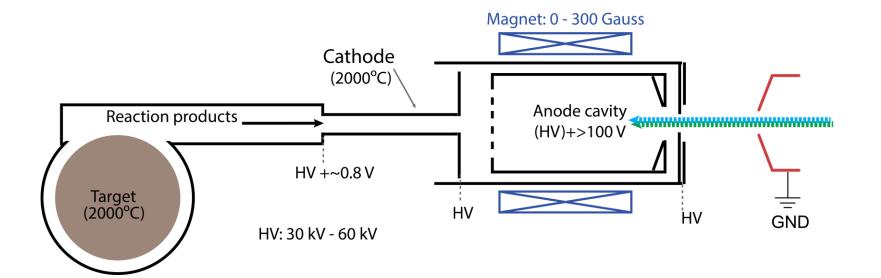
frequency offset (MHz)





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 - 3.3 RILIS
 - 3.4 Blurred boundaries







Versatile Arc Discharge and Laser Ion Source



Contents lists available at ScienceDirect

Nuclear Instruments and Methods in Physics Research B

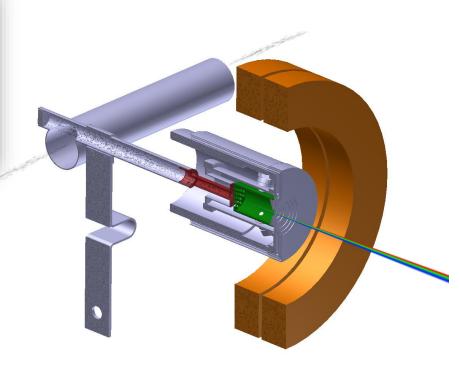
journal homepage: www.elsevier.com/locate/nimb

Blurring the boundaries between ion sources: The application of the RILIS inside a FEBIAD type ion source at ISOLDE

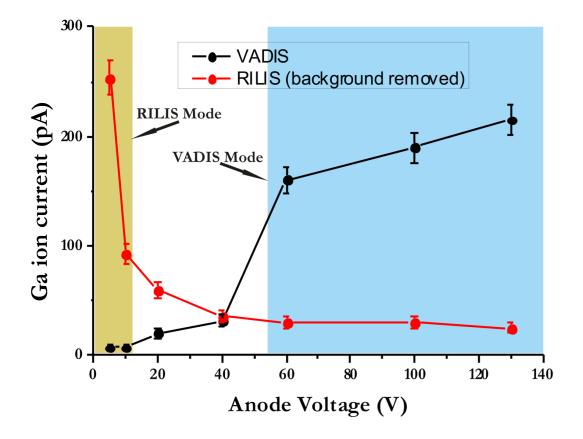
CrossMark

BEAM INTERACTIONS WITH MATERIALS AND ATOMS

T. Day Goodacre ^{a,b,*}, J. Billowes^b, R. Catherall^a, T.E. Cocolios^b, B. Crepieux^a, D.V. Fedorov^c, V.N. Fedosseev^a, L.P. Gaffney^{e,1}, T. Giles^a, A. Gottberg^a, K.M. Lynch^a, B.A. Marsh^a, T.M. Mendonça^a, J.P. Ramos^{a,d}, R.E. Rossel^{a,f,g}, S. Rothe^a, S. Sels^e, C. Sotty^e, T. Stora^a, C. Van Beveren^e, M. Veinhard^a

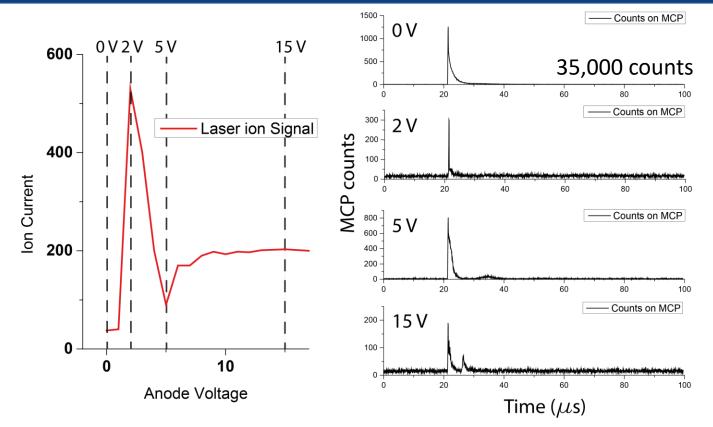








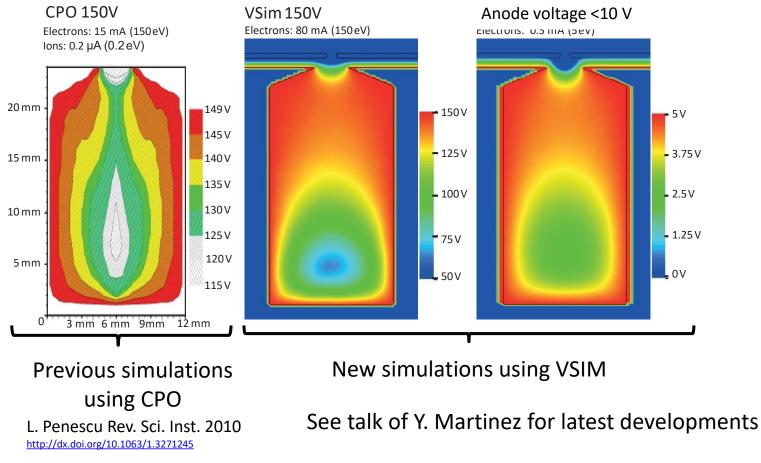
RILIS: developments:<u>VADLIS</u>



Ion survival was again found to be key to efficiency



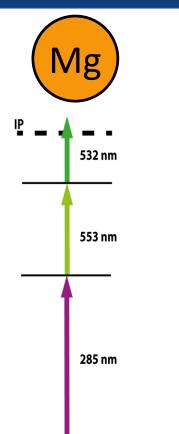
RILIS: developments:<u>VADLIS</u>



16th October 2017



Why bother with ion source development?



Experiment requiring ion beams of Mg, Ne and Na! Initial plan: only VADIS ionized beams

EUROPEAN ORGANIZATION FOR NUCLEAR RESEARCH

Proposal to the ISOLDE and Neutron Time-of-Flight Committee

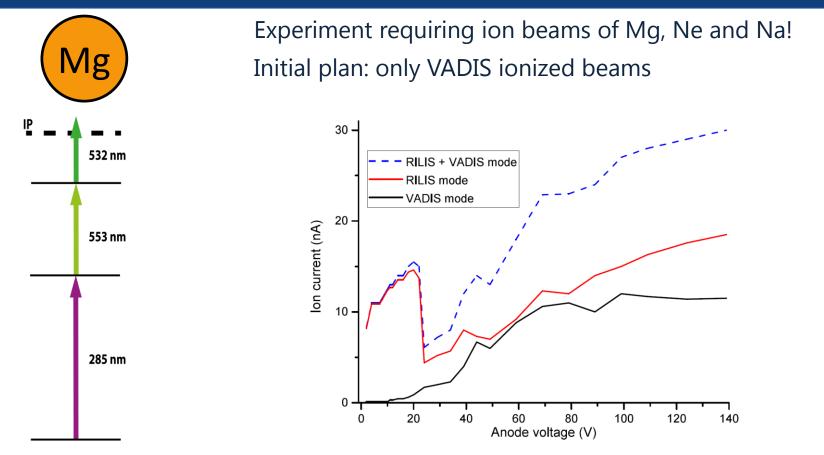
Q-values of Mirror Transitions for fundamental interaction studies

May 28th 2013

M. Breitenfeldt¹, D. Atanasov², K. Blaum², T. Eronen², P. Finlay¹, F. Herfurth³, M. Kowalska⁴,
 S. Kreim⁴, Yu. Litvinov³, D. Lunney⁵, V. Manea⁵, D. Neidherr³, T. Porobic¹, M. Rosenbusch⁶,
 L. Schweikhard⁶, N. Severijns¹, F. Wienholtz⁶, R.N. Wolf⁶, K. Zuber⁷



Why bother with ion source development?

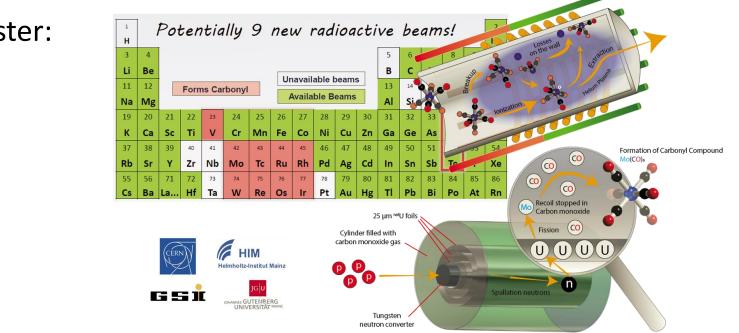


Developments towards refractory metal ion beams at ISOLDE

Volatile Carbonyl Compounds for New Refractory Beams at ISOLDE

J. Ballof^{1,2}, C. Seiffert¹, Ch. E. Düllmann^{2,3,4}, J. P. Ramos¹, S. Rothe¹, T. Stora¹, A. Yakushev^{3,4}

Johannes Gutenberg - Universität Mainz, Saarstr. 21, 55122 Mainz, Germany
 CERN, Engineering Department, ISOLDE, 1211 Geneva 23, Switzerland
 GSI Helmholtzzentrum für Schwerionenforschung GmbH, Planckstr. 1, 64291 Darmstadt, Germany
 Helmholtz-Institut Mainz, Johannes Gutenberg-Universität, 55099 Mainz



ICIS 2017 Poster:

Tuesday #68 J. Ballof

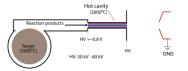




- 1. What is a thick target ISOL facility?
- 2. What does this mean for ion source requirements?
- Ion source types: challenges, development highlights and directions for the future
 3.1 Surface ion sources
 - 3.2 FEBIAD type ion sources
 - 3.3 RILIS
 - 3.4 Blurred boundaries
- 4. Summary

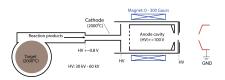


Summary



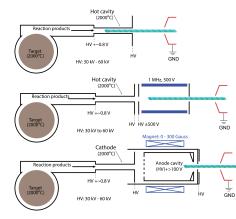
Surface ion source: •

- Selectivity possible for certain elements
- Lots of scope for materials development



FEBIAD ion source:

- Selectivity possible with temperature controlled transfer lines
- Simulations for optimization ongoing



16th October 2017

RILIS ion source:

- Ionization scheme development to further broaden the scope
- Laser atom interaction region development to reduce isobaric contamination and push the boundaries of selectivity



Many thanks to everyone who provided material for the presentation:

J. Ballof, K. Chrysalidis, D.V. Fedorov, V.N. Fedosseev, S. Franchoo, A. Gottberg, R. Heinke, N. Lecesne, J. Lassen, Y. Liu, F. Maldonado, B.A. Marsh, Y. Martinez.





Canada's national laboratory for particle and nuclear physics and accelerator-based science

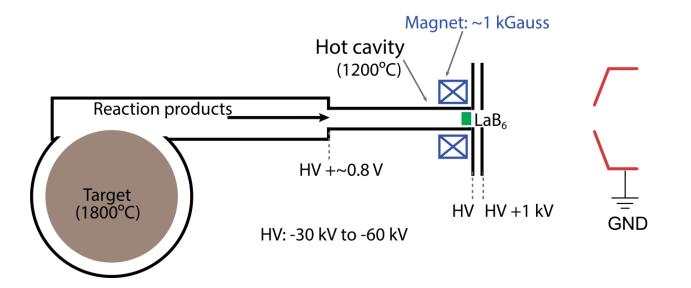
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Thank you! Merci!

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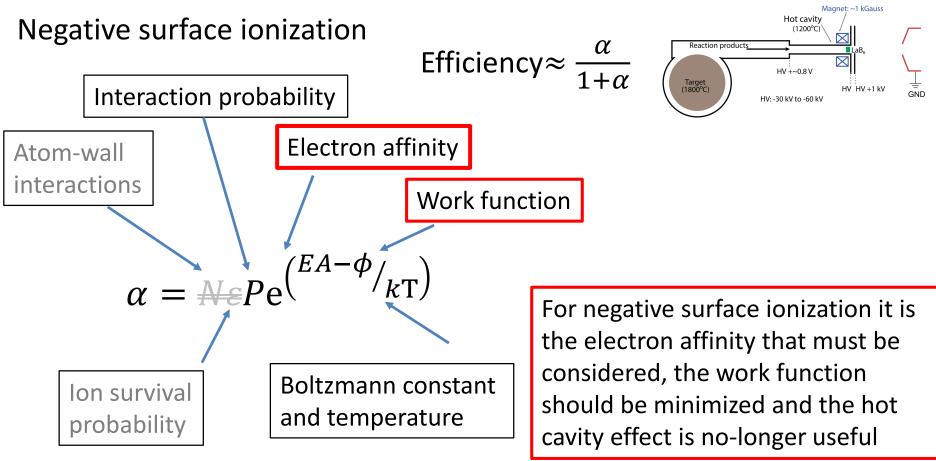
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RTRIUMF

Surface ion sources (Negative)

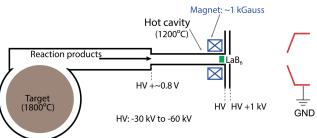




- 1. Efficiency: electron affinity and cavity work function dependent
- 2. Extraction/ionization time ~100 μ s (not considering sticking times)
- 3. Chemical selectivity: significant

	1	2	3	4	5	6	7	8	9	10	11	12	13	14	15	16	17	18	
1	1 H																	2 He	•
2	3 Li	4 Be											5 B	6 C	7 N	8 0	9 F	10 Ne	· •
3	11 Na	12 Mg											13 Al	14 Si	15 P	16 S	17 Cl	18 Ar	•
4	19 K	20 Ca	21 Sc	22 Ti	23 V	24 Cr	25 Mn	26 Fe	27 Co	28 Ni	29 Cu	30 Zn	31 Ga	32 Ge	33 As	34 Se	35 Br	36 Kr	
5	37 Rb	38 Sr	39 Y	40 Zr	41 Nb	42 Mo	43 Tc	44 Ru	45 Rh	46 Pd	47 Ag	48 Cd	49 In	50 Sn	51 Sb	52 Te	53 I	54 Xe	
6	55 Cs	56 Ba		72 Hf	73 Ta	74 W	75 Re	76 Os	77 Ir	78 Pt	79 Au	80 Hg	81 Tl	82 Pb	83 Bi	84 Po	85 At	86 Rn	
7	87 Fr	88 Ra		104 Rf	105 Db	106 Sg	107 Bh	108 Hs	109 Mt	110 Ds	111 Rg	112 Cn	113 Uut	114 Uuq	115 Uup	116 Uuh	117 Uus	118 Uuo	I
	Lanthanides			57 La	58 Ce	59 Pr	60 Nd	61 Pm	62 Sm	63 Eu	64 Gd	65 Tb	66 Dy	67 Ho	68 Er	69 Tm	70 Yb	71 Lu	
	Actinides				90 Th	91 Pa	92 U	93 Np	94 Pu	95 Am	96 Cm	97 Bk	98 Cf	99 Es	100 Fm	101 Md	102 No	103 Lr	

- Particularly applicable for Halogens
- Scope for improvement in efficiency and lifetime...



16th October 2017



ICIS 2017 Poster: David Leimbach

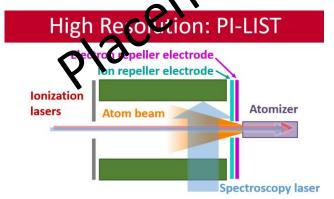
Towards Isobar-Free High-Resolution In-Source Spectroscopy On-Line: New Features of the Laser Ion Source & Trap LIST



R. Heinke¹, V. Fedosseev², T. Kron¹, B. Marsh¹, S. Rauder⁵, T. Reich⁴, S. Richter¹, S. Rothe^{2,5}, P. Schönberg⁴, M. Trümper¹, C. Weichhold¹ and K. Wendt¹



¹Institute of Physics, Mainz University – ²EN Department, CERN, Geneva – ³GSI, Lumsua ⁴nstitute of Nuclear Chemistry, Mainz University – ⁵University of Manchester



The Perpendicularly Illuminated Laser Ion Source & Trap **PI-LIST**



ICIS 2017 Poster: Sebastian Rothe

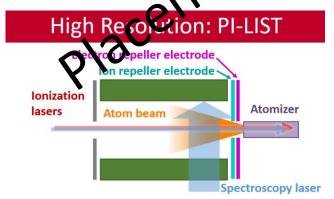
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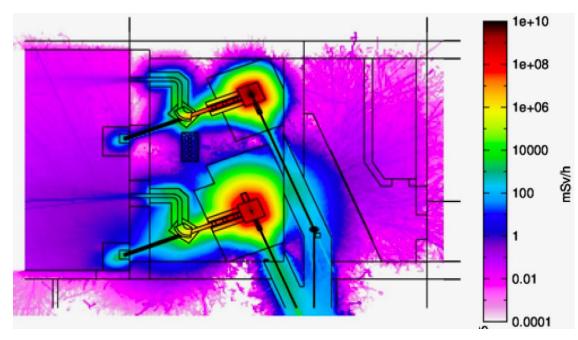


The Perpendicularly Illuminated Laser Ion Source & Trap **PI-LIST**

Ion source requirements @ thick target ISOL

- 1. Efficiency
- 2. Extraction/ionization time
- 3. Ion beam quality
- 4. Chemical selectivity
- 5. Survival
- Extreme radiation fields
- Temperatures up to 2300°C
- Thermal cycling
- Inaccessibility

Expected dose rates @ARIEL target level



A. Gottberg

RIUMF

Ion source requirements @ thick target ISOL

- 1. Efficiency
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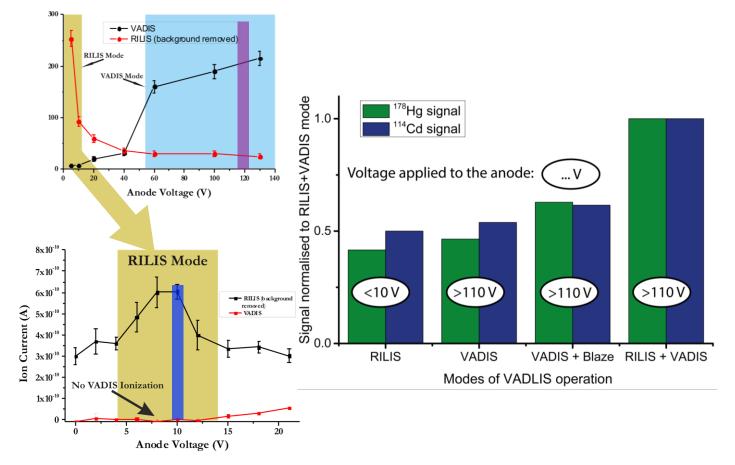
ISAC target off-line acceptance tests



A. Schmidt

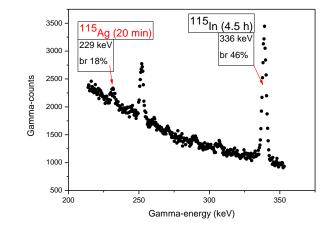


RILIS: developments:<u>VADLIS</u>



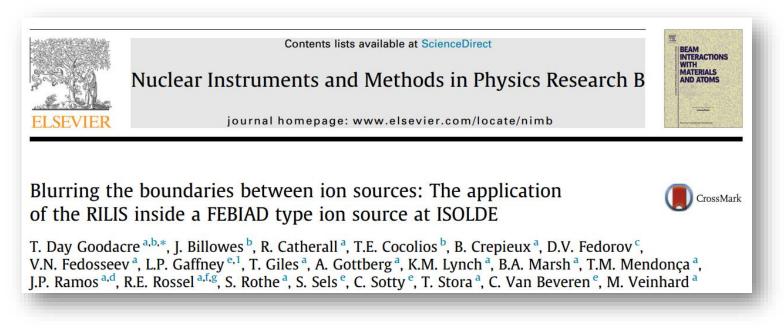


Blurred boundaries: developments

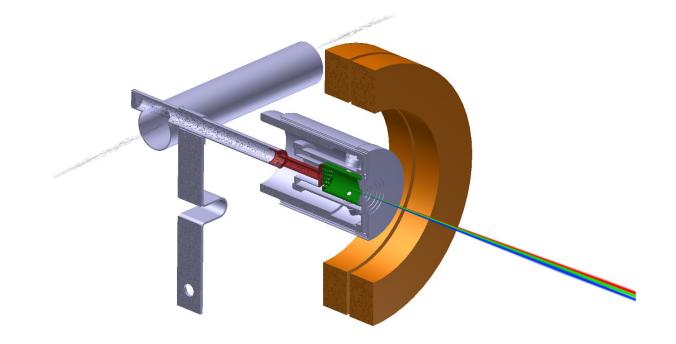




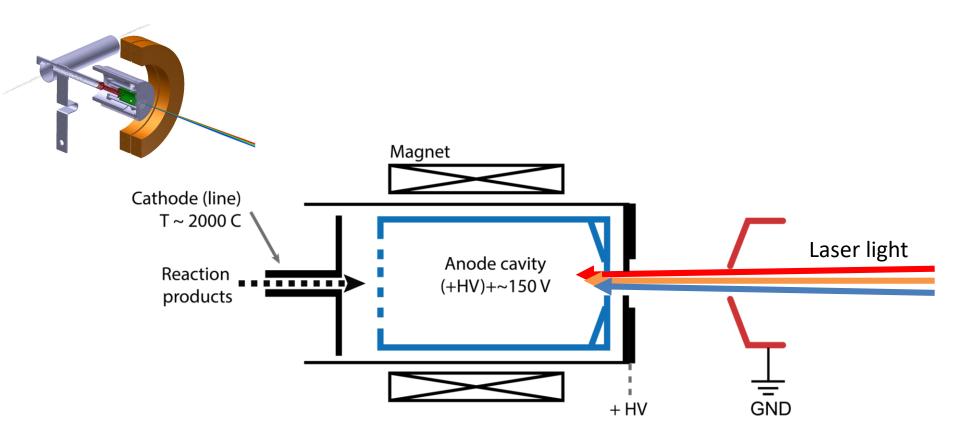
Compatibility with RILIS systems





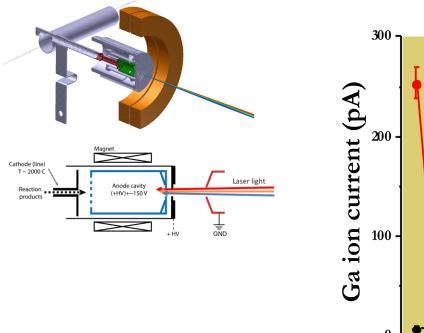


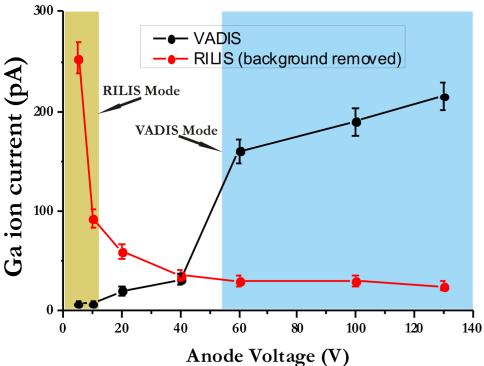






What can developments bring?



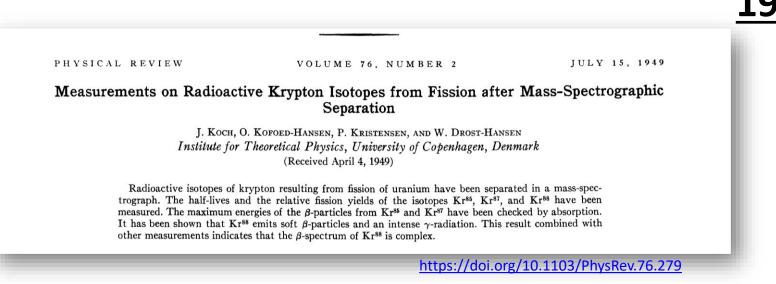




Where and how?



ISOL = Isotope Separator On-Line



"Ten kilograms of powdered uranium oxide, mixed with a small portion of ammonium carbonate, were placed in a glass container which was surrounded by a few centimetres of paraffin... The uranium container was inserted between the coils of the cyclotron magnet... and then heavily irradiated for about three hours..."



The Birth of ISOL

